



AMCM M 290 Dual FDR

Dual head, fine detail resolution AM system.

Optimized for your applications.



AMCM M 290 Dual FDR

BENEFITS

- Fine detail resolution (FDR) for demanding applications
- High productivity with dual laser setup
- Option for parameter set transfer from M 280 FDR or M 100 ASG (same focus, beam quality, etc.) (1)
- Process gas cooling for consistant process conditions (optional)
- Open software for process optimization

TECHNICAL DATA

Building volume	250 x 220 x 325 mm 9.85 x 8.66 x 12.8 in (2)
Laser type	Yb Fiber laser 2x 400 W nominal power
Wave length	1070 nm
Precision optics	F-theta-lens
Scanner	digital scanner with active cooling
Scanning speed	up to 7,0 m/s 23 ft./sec
Focus diameter	approx. 40 μm 0.0016 in
Process gas cooling	additional gas cooling unit (optional)
Power supply	ca. 32 A / 400 V
Power consumption	max. 20 kW
Inert gas supply	7.000 hPa; 20 m³/h 102 psi; 706 ft³/h
Dimensions (W x D x H)	2.500 x 1.300 x 2.400 mm 98.4 x 51.2 x 94.49 in
Recommended installation space	min. 4.800 x 3.600 x 3.500 mm 189 x 142 x 138 in
Weight	approx. 1.350 kg 2,976 lb

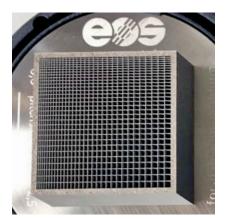


Fig 1: Example of an anti-scatter grid (ASG) (4) produced on a EOS M 100 ASG with similar optics as on M 290 Dual FDR.

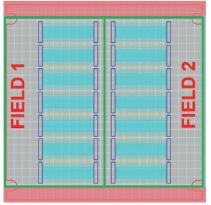


Fig 2: Exposure area of scan field 1 and scan field 2 (3)

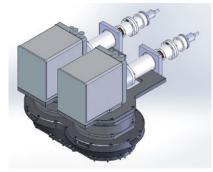


Fig 3: M 290 Dual FDR scanner setup

AMCM GmbH

Petersbrunner Straße 1b

⁽¹⁾ Processes must all be re-qualified by customer.

Consulting for parameter set transfer from M 280 FDR or M 100 to M 290 Dual FDR on request.

 $^{^{(2)}}$ Effective exposure area per scanner is XY 135 x 220 mm. Parts inside overlap area of the two scan fields should be built with a single laser. Recommended maximal part size XY 125 x 220 mm.

 $^{^{(3)}}$ Overlap calibration and scan field adjustment for M 290 Dual FDR not available.

⁽⁴⁾ Recommended max. building height for ASG application with Tungsten Z = 100 mm due to high weight.